



MAR 28 2005

Attorney Docket No. 09792909-5337

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of ) Group Art Unit 2814

) Hideo Yamanaka et al.

Application No. 10/075,774

Filed: February 14, 2002

For: METHOD AND APPARATUS FOR  
FORMING A THIN SEMICONDUCTOR  
FILM, METHOD AND APPARATUS FOR  
PRODUCING A SEMICONDUCTOR  
DEVICE, AND ELECTRO-OPTICAL  
APPARATUS

) Examiner: Hoa B. Trinh

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Enrique Perez

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

*Entered by  
RCC filed 5/25/05  
SDavis 6/2/05*

**RESPONSE TO FINAL OFFICE ACTION**

Dear Sir:

This Amendment is filed in response to the Office Action of January 25, 2005. Please  
reconsider the application in view of the amendment and remarks presented below.

Amendments to the claims start on page 2.

Remarks start on page 14.